

ELECTRONIC INFORMATION DISCLOSURE STATEMENT

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Title of Invention	IMPROVING SYSTEMATIC YIELD IN SEMICONDUCTOR MANUFACTURE
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Application Number :

Confirmation Number:

First Named Applicant: Paul Bergeron

Attorney Docket Number: BUR920040134US1

Art Unit:

Examiner:

Search string: (6341366 or 6421814 or 6430733 or 6711725 or 6189132 or 6434732 or 6260183 or 6178543 or 5636133 or 5987086 or 5923059 or 20030005401 or 20040019862).pn

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	1	6341366	2002-01-22	Wang et al.			
	2	6421814	2002-07-16	Ho			
	3	6430733	2002-08-06	Cohn et al.			
	4	6711725	2004-03-23	Rutenbar et al.			
	5	6189132	2001-02-13	Heng et al.			
	6	6434732	2002-08-13	Juengling			
	7	6260183	2001-07-10	Raspopovic et al.			
	8	6178543	2001-01-23	Chen et al.			
	9	5636133	1997-06-03	Chesebro et al.			
	10	5987086	1999-11-16	Raman et al.			
	11	5923059	1999-07-13	Gheewala			

US Published Applications

Note: Applicant is not required to submit a paper copy of cited US Published Applications

init	Cite.No.	Pub. No.	Date	Applicant	Kind	Class	Subclass
	1	20030005401	2003-01-02	Wimer			
	2	20040019862	2004-01-29	Li et al.			

Signature

Examiner Name	Date